

RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1734

PATENT

Attorney Docket No. 02887.0271

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:	,
Tetsuya KUROSAWA et al.) Group Art Unit: 1734
Application No.: 10/808,298) Examiner: Osele, Mark A.
Filed: March 25, 2004) Confirmation No.: 5493
For: SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE) Mail Stop AF)))))
Commissioner for Patents	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed April 5, 2006, the period for response to which extends through July 5, 2006, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.